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## JAN 29 2008

## EXTRUSION FREE WET CLEANING PROCESS

Appl. No.

: 10/710,522

Confirmation No. : 4521

Applicant

: Chung-Chih Chen

Filed

: July 18, 2004

TC/A.U.

: 1792

Examiner

: TADAYYON ESLAMI,

TABASSOM

Docket No.

: NAUP0598USA

Customer No. : 27765

Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

## AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION

In response to the Office action of December 4th, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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